REMARKS

The Examiner restricted examination of claims 1-28 in this application.

Specifically, the Examiner restricted claims 1-12 to Group I as directed to a method and claims 13-28 to Group II as directed to an apparatus. The Examiner asserted that the method claims in Group I are distinct from the apparatus claims in Group II because "the method can be accomplished in a conventional furnace or oven with preset temperatures and time." See Office Action, page 2. Although Applicants do not necessarily agree with the Examiner's reasons for restriction, Applicants elect to prosecute claims 1-12 of Group I. Therefore, Applicants cancel claims 13-28 of Group II without prejudice for possible inclusion in a divisional application. Lastly, Applicants note that claim 12 of Group I is a claim to a semiconductor wafer and is not a method claim. Reconsideration of the present application as amended is respectfully requested.

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If the Examiner believes that a telephonic interview will help speed this application toward issuance, the Examiner is invited to contact the undersigned at the telephone number listed below.

Respectfully submitted,

Date: August 29, 2005

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